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Pavel Zemánek
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Introduction

This conference is a continuation of a series of regular meetings of the Czech, Polish, and Slovak optical communities which started in Rusava (Czech Republic) in 1972. After a short interruption between 1980 and 1990, the meetings have grown, and are known as the "Wave and Quantum Aspects of Contemporary Optics." For 40 years, this conference has been organized biannually by turns in Slovakia, Czech Republic, and Poland, and has become a place to exchange knowledge on the latest optical research, and to meet friends and coworkers, as well as young scientists.

Pavel Zemánek

